

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Date: July 26, 2006

Etsuro Morita, Akihiko Endo

Filed: July 26, 2006

Our Docket: SHX 373

For: METHOD FOR MANUFACTURING SOI WAFER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.56, 1.97, and 1.98

Applicants are submitting this Information Disclosure Statement pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98 to disclose to the U.S. Patent and Trademark Office the patents, publications, applications, and/or other references listed on the enclosed, completed PTO-1449 form(s). The filing of this Information Disclosure Statement should not be construed as a representation that a search has been made or as an admission that the listed references are prior art for this application. Applicants respectfully request that the listed references be expressly considered during prosecution of the application, and that the references be made of record therein and appear among the "references cited" on any patents issuing therefrom.

CONTENT OF DISCLOSURE

This Information Disclosure Statement includes (1) one page of PTO-1449 forms, and (2) a legible copy of each foreign and non-patent reference, if any, listed on the form(s). However, because this application was filed on or after July 1, 2003, no copies of U.S. patents or published U.S. patent applications are included.

FOREIGN-LANGUAGE REFERENCES

A concise explanation of the relevance of each listed reference not in the English language is attached to each reference.

TIMING OF DISCLOSURE / FEE INFORMATION

This Information Disclosure Statement is being filed with the application or with a Request for Continued Examination of the application under 37 C.F.R. §1.114. Therefore, in accordance with 37 C.F.R. § 1.97(b), no fee or statement under 37 C.F.R. § 1.97(e) is required.

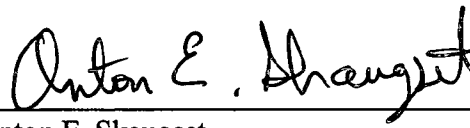
Please contact the undersigned with any questions or comments regarding this Information Disclosure Statement.

"Express Mail" Mailing Label No.
EV 370647069US
Date of Deposit - July 26, 2006

I hereby certify that the attached correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. 1.10 on the date indicated above and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.


Suzanne Lukas-Werner

Respectfully submitted,
KOLISCH HARTWELL, P.C.


Anton E. Skaugset
Registration No. 38,617
Customer No. 23581
520 S.W. Yamhill Street, Suite 200
Portland, Oregon 97204
Telephone: (503) 224-6655
Facsimile: (503) 295-6679
Attorney/Agent for Applicant/Assignee

10/587725

10/587725 23 JUL 2009

SHEET 1 OF 1

FORM PTO-1449		DOCKET NUMBER SHX 373		APPLICATION NUMBER		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		APPLICANT(S) Etsuro Morita				
		FILING DATE July 26, 2006		GROUP ART UNIT		
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FIL. DATE IF APPROP.
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES NO
	02-228061	9/11/1990	Japan			X
	05-129258	5/25/1993	Japan			X
	09-116125	5/2/1997	Japan			X
	11-145074	5/28/1999	Japan			X
	2000-124092	4/28/2000	Japan			X
	WO 2004/010505A1	1/29/2004	WIPO			X
OTHER DOCUMENTS						
	International Search Report dated April 14, 2005 for International Application No. PCT/JP2005/001226.					
EXAMINER	/Candice Chan/		DATE CONSIDERED 04/27/2009			

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /CC/